PATENT 0756-1998 #6/LD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

Shunpei YAMAZAKI, et al.

Group:

2811

Serial No.:

09/352,194

) Examiner:

Unknown

Filed:

July 13, 1999

)

Title:

CRYSTALLINE SEMICONDUCTOR THIN

FILM, METHOD OF FABRICATING THE

SAME, SEMICONDUCTOR DEVICE, AND )

METHOD OF FABRICATING THE SAME

FAX COPY RECEIVED

INFORMATION DISCLOSURE STATEMENT

and

CROSS-REFERENCING OF RELATED APPLICATION

MAY 2 5 2000

**TECHNOLOGY CENTER 2800** 

Honorable Assistant Commissioner of Patents Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. § 1.56 and 37 C.F.R. §§ 1.97-1.99, it is requested that the reference listed on the attached PTO-1449 form be made of Record in the above-identified application. Copies of the reference are submitted herewith in accordance with 37 C.F.R. § 1.98(a).

Applicants are submitting this Information Disclosure Statement before the mailing date of a first Office Action on the merits.

The Examiner's attention is directed to U.S. Patent Application No. 09/352,198.

The Commissioner his hereby authorized to charge fees under 37 C.F.R. §§ 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

**CERTIFICATE OF MAILING** 

Respectfully submitted,

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient purished as First Class Mail in an environmental transed to: Assistant Contries.

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